

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1746

PATENT APPLICATION
Docket No.: 2522-042
Client Ref. No.: AW8122US/PJ

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Eun-Taek YIM, et al.

Serial No.: 10/734,479 Examiner: Chaudry, Saeed T.

Filed: December 12, 2003 Art Unit: 1746

Confirmation No.: 9601

For: METHOD FOR CLEANING A DEPOSITION CHAMBER AND
DEPOSITION APPARATUS FOR PERFORMING IN SITU
CLEANING

Date: November 20, 2006

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Entry
5/11/29/06

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Responsive to the Final Office Action, Paper No. 20060914, dated September 18, 2006, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper